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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

912

APPL NUM 10076630	FILING DATE 02/19/2002	CLASS 438	SUBCLASS	GAU 2812	EXAMINER
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**APPLICANTS: Chung Chia-Chi; Hsueh Chen-Chen;

**CONTINUING DATA VERIFIED:

** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiner's initials		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO 8409.0004-00
TITLE : Self-aligned patterning in dual damascene process			
U.S.DEP'T. OF COMM./PAT. & TM-PTO-438L(Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
Amount Due	Date Paid		Total Claims	Print Claim for O.G.
		Primary Examiner	DRAWING	
			Sheets Drwg. 2	Figs. Drwg. 6
			Print Fig. 3,4,5	
		PREPARED FOR ISSUE	Application Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368. Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.		

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